

## **PATENT APPLICATION**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)
	: Examiner: A. A. Mathews
Akihiro NAKAUCHI et al.	) : Group Art Unit: 2851
Application No.: 09/845,297	)
71	: Confirmation No.: 3006
Filed: May 1, 2001	)
	: Allowed: September 24, 2003
For: PROJECTION EXPOSURE	)
APPARATUS HAVING ABERRATION	: December 24, 2003
MEASUREMENT DEVICE	)

## **Mail Stop RCE**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## PRELIMINARY AMENDMENT

Sir:

Prior to further examination on the merits, please amend the above-identified application as follows: